(19) World Intellectual Property Organization International Bureau



(43) International Publication Date 5 July 2001 (05.07.2001)

PCT

(10) International Publication Number WO 01/47803 A1

- (51) International Patent Classification⁷: C01B 13/10, B01J 19/08, H01T 23/00, F02M 27/00, A45D 19/16
- (21) International Application Number: PCT/US00/35401
- (22) International Filing Date:

22 December 2000 (22.12.2000)

(25) Filing Language:

English

(26) Publication Language:

English

(30) Priority Data: 60/173,075

24 December 1999 (24.12.1999) US

- (71) Applicant and
- (72) Inventor: LEE, Jim, L. [US/US]; 5430 Commerce Blvd., Rohnert Park, CA 94928 (US).
- (74) Agents: JOHNSON, Larry, D. et al.; Johnson & Stainbrook, LLP, Suite 203, 3550 Round Barn Boulevard, Santa Rosa, CA 95403 (US).

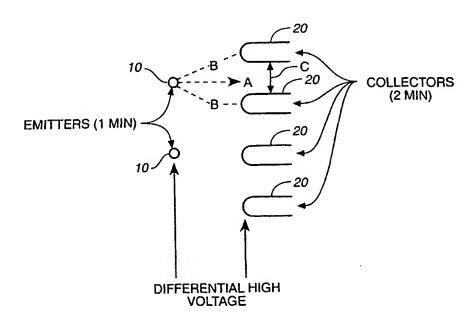
- (81) Designated States (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CR, CU, CZ, DE, DK, DM, DZ, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NO, NZ, PL, PT, RO, RU, SD, SE, SG, SI, SK, SL, TJ, TM, TR, TT, TZ, UA, UG, US, UZ, VN, YU, ZA, ZW.
- (84) Designated States (regional): ARIPO patent (GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZW), Eurasian patent (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European patent (AT, BE, CH, CY, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE, TR), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, GW, ML, MR, NE, SN, TD, TG).

Published:

With international search report.

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

(54) Title: METHOD AND APPARATUS TO REDUCE OZONE PRODUCTION IN ION WIND DEVICES



(57) Abstract: A method to limit ozone production in wind ion devices while simultaneously realizing incidents of high acceleration in such devices varies the high voltage potential across the array of emitter(s) (10) and collectors (20) over time in such a manner as to generate a wave effect of airflow. The variance may be achieved by switching, ramping, or gating the high voltage potential delivered to the array.

01/47803 A

1

METHOD AND APPARATUS TO REDUCE OZONE PRODUCTION IN ION WIND DEVICES

5

10

15

20

25

30

BACKGROUND OF THE INVENTION

Technical Field

This invention relates generally to ion generators and ion wind devices, and more specifically to an improved method and apparatus for reducing the production of ozone in ion wind devices.

Background Art

Ion wind devices such as described in Lee U.S. Patent No. 4,789.801 (incorporated herein by reference) provide accelerated gas ions generated by the use of differential high voltage electric fields between an array of one or more emitters and a plurality of collectors (accelerators). The ions are entrained in the ambient bulk gases, causing the gases to flow. Gas velocities can reach as high as eight hundred feet per minute. However, the high voltage electric fields used to generate the gas ions and provide the force necessary for gas acceleration are also responsible for creating molecular dissociation reactions, the most common of which include ozone generated from oxygen when such devices are operating in a breathable atmosphere. It is an object of this invention to provide methods to reduce the production of ozone in such devices.

The U.S. Food and Drug Administration has determined that indoor airborne ozone in concentrations above 50 ppb (parts per billion) may be hazardous to humans. NIOSH has ruled that indoor concentrations of ozone above 100 ppb may be hazardous to humans. Devices which utilize high voltage electric fields to generate atmospheric plasma, corona discharge and air ions are all susceptible to generating the allotrope, ozone. There exists a linear relationship between the level of the high voltage fields and current and the level of ozone concentration in most direct current operated ion wind systems. Also, a linear relationship exists between the acceleration velocity and intensity of the electric fields. Typically the higher the voltage the higher the acceleration. Since it is desired to have maximum acceleration, methods must be employed to limit or eliminate unwanted ozone

WO 01/47803

2

PCT/US00/35401

production.

5

10

15

20

25

30

Disclosure of Invention

Ion wind devices accelerate gas ions by applying differential high voltage electric fields between one or more emitters and a plurality of collectors (accelerators). The inventive method limits ozone production while simultaneously realizing incidents of high acceleration in such devices by varying the high voltage potential across the array of emitter(s) and collectors over time in such a manner as to generate a "wave effect" of airflow. Several alternative methods of varying the high voltage potential have proven successful in accomplishing this wave effect. One method, which may be referred to as a switching method, allows the positive emitter high voltage potential to operate at a reduced level (e.g., + 6 KV) for a period of time (e.g., three seconds), and then switch to a higher potential (e.g., +8.5 KV) for another, and preferably shorter period of time (e.g., one second). The result is that at the lower (less ozone generating level) airflow is simultaneously reduced. However, when switched from the lower to the higher potential for one second higher airflow is momentarily achieved due to accelerated ion momentum. The overall average airflow is slightly higher than the linear three to time ratio due to ion momentum transfer and resulting inertia from it.

An alternative method, which may be referred to as a ramping method, accomplishes the wave effect by use of an electronic circuit to generate a nonlinear sawtooth ramp driving voltage. Typical ramp duration would also be, e.g., four seconds, with the ending portion and trailing edge effecting the highest voltage state for approximately one second. In both the switching method and ramping method airflow velocities were varied typically from a low state of 300 feet per minute to a high state of 500 feet per minute. Subsequent ozone production levels varied from a low of 17ppb for 3 seconds to a high of 50ppb for less than one second. Overall average ozone production was less than 25 ppb. This represents an improvement over operating the same array at a steady state of 350 feet per minute and generating an average of 35 ppb ozone. Furthermore, the burst of 500 feet per minute of airflow improves perceptible operation of the ion wind device.

A further alternate method which also produces the wave effect may be referred to as a gate method, which is a gate voltage which switches either (or both) the positive high voltage to the emitter or the negative high voltage to the collector at timed intervals, such as

3

20 seconds off and then 20 seconds at the high voltage state. Finally, either the switching method, the ramping method or the gate method may be used in concert with each other or with other ozone control.

Brief Description of the Drawings

5

10

15

20

25

30

Fig. 1 is a schematic view of an emitter and collector (accelerator) array of an ion wind device;

Fig. 2 is a schematic view of the switching method of varying the high voltage potential between the emitter(s) and collectors of this invention;

Fig. 3 is a schematic view of the ramping method of this invention; and

Fig. 4 is a schematic view of the gate method of this invention.

Best Mode for Carrying Out the Invention

Fig. 1 refers to a typical ion wind array such as described in Lee U.S. Patent No. 4,789,801. The emitter or emitters 10 are typically constructed of .1 mm pure tungsten wire and may be of any length. The collectors (sometimes referred to as accelerators) 20 are typically constructed of any non corrosive conductive material such as copper, aluminum, stainless steel, or brass. The emitter 10 is always located opposite and at the center (A) of the opening of the collectors 20. The equidistant (B) of the emitter 10 to the leading edge (radius) of the collector 20 may vary depending upon desired operational effect, but is typically one inch. This is also true of the spacing (C) between the collectors 20.

The differential voltage applied across the emitter/collector array must be at least 6,500 volts in order to effect any substantial ion mobility and subsequent airflow. Typical configurations consist of applying a positive high voltage to the emitter 10 and a negative high voltage to the collector 20 to achieve a maximum differential voltage of 15,000 volts D.C. These voltage potentials may be reversed, however, when this is done an uneven plasma envelope is developed at the emitter source, which results in excessive corona noise and ozone production. Alternatively, the array may be driven by a single positive or single negative high voltage excitation source to the emitter 10 with the collectors 20 having a high impedance return to ground (to reduce load current and breakover arcing). Also, the excitation voltage may be modulated in ways taught U.S. Patent No. 4,789,801 to achieve desired results.

Fig. 2 is a schematic view of the switching method of this invention. This method provides a pulsed high voltage to the emitter/collector array, i.e., a high voltage excitation configuration to drive the array by switching from a lower-level positive high voltage state HV1 to a higher-level positive high voltage state HV2 at pre-determined time intervals, e.g., one second HV1 and three seconds HV2. It is not necessary to include the negative voltage reference -HV if the positive voltage is increased proportionally to achieve like airflow levels. Also, the voltage polarities may be reversed with minimal effect upon the airflow levels.

Fig. 3 is a schematic view of the ramping method of this invention. This method provides a ramped high voltage to the emitter/collector array, i.e., a high voltage excitation configuration to drive the array with a voltage ramp, which changes in amplitude over a variable time interval. The low-level high voltage on time state may typically be as long as 5.5 seconds for minimal ozone production. Conversely, the low-level high voltage may be as short as 2.5 seconds for maximum desired ozone. The ramp up time is typically 1.5 seconds to create a differential voltage in excess of 14,000 volts. Actual time and amplitude may be varied for effect depending upon desired airflow and ozone levels.

Fig. 4 is a schematic view of the gate method of this invention. This method provides a sequential high voltage to the emitter/collector array, i.e., a high voltage gating (or switching on/off) method whereby the differential high voltage applied to the array is turned from a zero state to a maximum high state at pre-determined intervals. The on/off timed states and differential amplitude may be varied for effect. For example, a 20-second on to 20 second off time and a differential high voltage level of 15,000 volts would be the maximum duty cycle and amplitude for airflow and ozone output. As in the switching and ramping methods, supra, it is not absolutely necessary to use a negative high voltage on the collector array if the voltage level is increased proportionally on the emitter array, since the airflow and ozone levels will change proportionally in like ambient conditions. However, a negative voltage applied to the collector array is usually used to improve contaminant collection, limit circuit cost and minimize corona arcing to neutral components located in the vicinity of the array housing.

5

CLAIMS

What is claimed as invention is:

1. A method of reducing ozone production in ion wind devices, said method comprising the steps of:

5

10

15

providing an emitter;

providing a plurality of collectors;

positioning said collectors generally equidistant from said emitter to form an array;

providing a high voltage potential between said emitter and said collectors;

and

varying said high voltage potential over time to generate a wave effect of airflow and reduce total ozone production.

- 2. The method of reducing ozone production in ion wind devices of claim 1 wherein said step of varying said high voltage potential over time comprises switching said high voltage potential from a lower high voltage level for a first period of time, to a higher high voltage potential for a second period of time.
- 3. The method of reducing ozone production in ion wind devices of claim 2 wherein said lower high voltage level is approximately +6 KV, and said higher high voltage potential is approximately +8.5 KV.

20

- 4. The method of reducing ozone production in ion wind devices of claim 2 wherein said first period of time is greater than said second period of time.
- 5. The method of reducing ozone production in ion wind devices of claim 4 wherein said first period of time is approximately 3 seconds, and said second period of time is approximately 1 second.

25

- 6. The method of reducing ozone production in ion wind devices of claim 1 wherein said step of varying said high voltage potential over time comprises providing a nonlinear ramp driving voltage to said emitter/collector array.
- 7. The method of reducing ozone production in ion wind devices of claim 6 wherein said nonlinear ramp driving voltage has a duration of approximately 4 seconds.

30

8. The method of reducing ozone production in ion wind devices of claim 6 wherein said nonlinear ramp driving voltage has an ending portion and trailing edge effecting the highest voltage state for approximately 1 second.

6

- 9. The method of reducing ozone production in ion wind devices of claim 1 wherein said step of varying said high voltage potential over time comprises providing a gating voltage to said emitter/collector array.
- 10. The method of reducing ozone production in ion wind devices of claim 9 wherein said gating voltage is turned from a zero state to a maximum high state at predetermined time intervals.

5

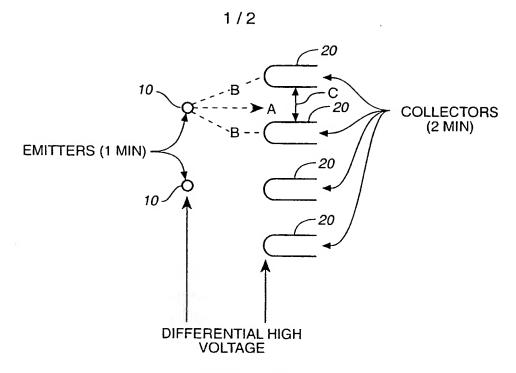
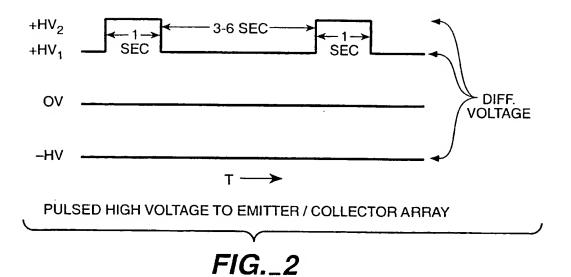
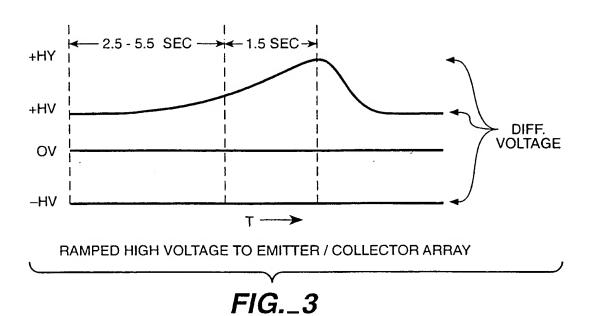


FIG._1



SUBSTITUTE SHEET (RULE 26)



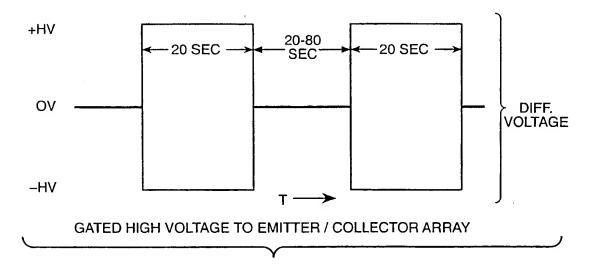


FIG._4

INTERNATIONAL SEARCH REPORT

International application No.
PCT/US00/35401

			· · · · · · · · · · · · · · · · · · ·				
A. CLASSIFICATION OF SUBJECT MATTER IPC(7) :C01B 13/10; B01J 19/08; H01T 23:00; F02M 27/00; A45D 19/16 US CL :Please See Extra Sheet. According to International Patent Classification (IPC) or to both national classification and IPC							
B. FIEL							
Minimum do	ocumentation searched (classification system followed	by classification symbols)					
U.S. : 1	Please See Extra Sheet.						
Documentati	Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched						
Electronic d	Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)						
C. DOC	UMENTS CONSIDERED TO BE RELEVANT						
Category*	Citation of document, with indication, where app	Relevant to claim No.					
Y,E	US 6,176,977 B1 (TAYLOR et al) 2 entire document.	1-10					
Y,E	US 6,812,671 B1 (TAYLOR et al) 0 entire document.	1-10					
Further documents are listed in the continuation of Box C. See patent family annex.							
	* Special categories of cited documents: "T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention.						
to	be of particular relevance	"X" document of particular relevance; th					
i	rlier document published on or after the international filing date ocument which may throw doubts on priority claim(s) or which is	considered novel or cannot be considered when the document is taken alone					
Cit	ted to establish the publication date of another citation or other secial reason (as specified)	"Y" document of particular relevance; th					
O do	ocument referring to an oral disclosure, use, exhibition or other eans	considered to involve an inventive combined with one or more other suc being obvious to a person skilled in	h documents, such combination				
	reument published prior to the international filing date but later than e priority date claimed	*&* document member of the same paten	t family				
Date of the	actual completion of the international search	Date of mailing of the international search report					
26 MAR	CH 2001 -	13 APR 2001					
Commission Box PCT	mailing address of the ISA/US oner of Patents and Trademarks	Authorized officer CHUC TRAN AMOREM					
Washington Facsimile	on, D.C. 20231 No. (703) 305-3230	Telephone No. (703) 306-5984	J				
L		·					

INTERNATIONAL SEARCH REPORT

International application No. PCT/US00/35401

A.	CLA	SSIFICA	TION	OF	SUBJECT	MAT	TER
110	. 01						

132/116, 154, 272, 112, 116, 148, 152, 271, 272; 204/176; 422/186.07; 361/226, 230, 232; 123/539, 272; 15/104.002, 246.3, 344, 345, 39.5, 40

B. FIELDS SEARCHED
Minimum documentation searched
Classification System: U.S.

132/116, 154, 272, 112, 116, 148, 152, 271, 272; 204/176; 422/186.07; 361/226, 230, 232; 123/539, 272; 15/104.002, 246.3, 344, 345, 39.5, 40

			·
÷.			